The new Rb vapour source

AWAKE collaboration meeting, CERN

05/10/2023

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- Vapour source for Run 2b
- Installation and commissioning
- Operations during Run 2b
- Further upgrades





Run 2b Vapour Source

- Same requirements as Run 1 for Rb density uniformity and max value as for Run1 and Run 2a $\delta T ({}^{\circ}K)/T({}^{\circ}K) \approx 0.2\%$
- Additionally have to implement a "sharp" (tens of cm) step from 1% to 10% δT (°K)/T(°K) from 5 to 50°C

Self modulator

Accelerator



Run 2b Vapour Source



- Stand alone electrically heated section with 5 zones (HPP)
- Tested in 2021 at CERN (EHN1)

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Installation and commissioning Plan of Reference 2022-23 Implementation Outline



Installation and commissioning











Run 2b Operations

- Downtime to impose the step (3%) passed from 1h40 to ~40min thanks to PID params and control algoritm optimization
- Thanks to support from control team, continuous development and upgrade of control software led to user friendly GUI for awake operator

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Run 2b Operations

Control GUI

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Run 2b Operations, critical points

- Main cause of downtime during run was OTCs (over temperature cutout circuits) failure, happened 4 times.
 Different causes (to close to threshold, loose connectors, probes cable impedance), needed hardware
 bypass in the tunnel. Now fixed with two intervention by WDL
- Other access needed to reboot the control rack for a failsafe card, now remote reset implemented and tested
- Density diagnostic tuned between first and second run, US spectrometer found with wrong factory calibration was giving incorrect values. Now fixed in software that calculate density, measurement between Up, Middle and Downstream viewport show agreement in 0.2%





Further upgrades

- Mu-metal shielding installation happening now in the tunnel
- Test of effect of magnetic field on electron bunch started, show some effect to be investigated more in details with Mu-metal
- Suppression mechanism already implemented, all heaters off for 200ms during proton passage through the experiment. Successfully Tested trigger on vapor source control system, to be tested with proton events
- Veto on expansion volume BTV and Rb reservoirs valves to minimize RB coating of screen in implementation phase
- Shorter plasma: Under study/design feasibility plungers with laser dump inside the vapor source, for a possible installation before 2024 Run.





Thank you for your attention





